

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Ting Kuo Chen : Group  
Serial No: 09/686,895 : Art Unit #2125  
Filed: 12 October 2000 : Examiner:  
Title: SMART AUTOMATIC RECORDING : M.N. Von  
Buhr  
SYSTEM AND METHOD FOR  
MONITORING WAFER FRAGMENTATION :

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RECEIVED**

JUL 16 2004

Technology Center 2100

Sir:

This is responsive to the non-Final Office Action dated 16 March 2004.  
A Request and fee for a one (1) month Extension of Time has been  
concurrently filed herewith.

Please amend the above-referenced Patent Application as follows:

**Amendments in the Drawings** begin on page 2 of this paper.

**Amendments in the Specification** begin on page 3 of this paper.

**Amendments to the Claims** are reflected in the Listing of Claims  
which begins on page 7 of this paper.

**Remarks** begin on page 12 of this paper.

**An Appendix** including two replacement drawing sheets of FIGS 3 and  
4, respectively, are attached following page 17 of this paper.